

APPLICANT'S ART CITATION (Use several sheets if necessary)		Application		OFGS File No. P729-1642			
		Applicant Munehiro ITO					
		Filing Date		Group Art Unit			
U.S. PATENT DOCUMENTS							
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate	
	US-						
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FOREIGN PATENT DOCUMENTS							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
JPL	7-78495 3/95	1995	Japan				X
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
	English translation of Abstract for Japanese Patent						
	Laid Open Application No. Hei 7 (1995)-78495						
Examiner John B. [Signature]	Date Considered 2/21/06						
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